

PATENT: 06491 USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLI-

CATION OF

Peng Zhang, et al.

SERIAL NO.

10/764,227

: GRP. ART UNIT:

1714

FILED

: 2

23 January 2004

: EXAMINER:

FOR

Immersion Lithography Fluids

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The Information Disclosure Statement submitted herewith is being filed within three months of the filing date of a national application other than a continued prosecution application under § 1.53(d); within three months of date of entry into the national stage as set forth in § 1.491 in an international application; before the mailing date of a first Office action on the merits; or before the mailing of a first Office action after the filing of a request for continued examination under § 1.114.

Respectfully submitted,

Rosaleen P. Morris-Oskanian Attorney for Applicant(s) Registration No. 47,321

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Substitute for form 1449/PTO			Complete if Known		
			Application Number	10/764,227	
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STATEMENT BY APPLICANT (Use as many sheets as necessary)			First Named Inventor	Peng Zhang, et al.	
			Art Unit	1714	
		Examiner Name			
14	of	2	Attorney Docket Number	06491 USA	
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U. S. PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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Sheet	2	of	2	Attorney Docket Number	06491 USA	

		NON PATENT LITERATURE DOCUMENTS	
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		W. CONLEY, et al., "New Fluids for 193nm Immersion Lithography," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	/
		S. ROBERTSON, et al., "Effects of Immersion Lithography on Diffusivity During PEB," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	~
		B. SMITH, et al., "Water-Based 193nm Immersion Lithography," Immersion Workshop held in conjunction with the Litho Forum of January 28, 2004 by International SEMATECH.	<u> </u>
	 		
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